



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: Yuko Ohgishi )

Application No. 10/806,588 )

Filed: March 23, 2004 )

For: METHOD OF PRODUCING  
SEMICONDUCTOR DEVICE AND  
SEMICONDUCTOR DEVICE )

Group Art Unit: 2812 )

Examiner: To be assigned )

**CERTIFICATE OF MAILING**

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*Suzarah Guevara*  
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Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**STATUS INQUIRY**

Sir:

With regard to the above-identified patent application that was filed in the U.S. Patent and Trademark Office on March 23, 2004, U.S. Serial No. 10/806,588, we have not yet received any communication from the U.S. Patent Office since issuance of the Notice of Publication of Application which was dated September 30, 2004. At this time, we respectfully request the current status of this application.

Dated: November 18, 2005

Respectfully submitted,

By:

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